## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Yuen et al.

Group Art Unit: 1763

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Examiner: George A. Goudreau

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Title: ETCHING A SUBSTRATE IN A

PROCESS ZONE

October 30, 2003

San Francisco, California

## AMENDMENT UNDER 37 C.F.R. 1.111

Commissioner for Patents

Via Facsimile Transmission (703) 872-9310

Examiner Goudreau:

This communication is in response to the Non-Final Office Action mailed on July 30, 2003, and is being timely filed within three months thereof.

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Date: October 30, 2003